

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/696,510	SPIEGELMAN ET AL.	
Examiner	Art Unit	
Teena Mitchell	3771	

SEARCHED				
Class	Subclass	Date	Examiner	
128	205.28 205.27 205.12 203.12	12/17/2007	TKM	
128	898,910	12/17/2007	TKM	
128	200.24	12/17/2007	TKM	
128	203.13	12/17/2007	TKM	
95	98 101-10 <b>5</b>	12/17/2007	TKM	
95	117	12/17/2007	TKM	
62	3.1 51.1	12/17/2007	ТКМ	
62	637	12/17/2007	TKM	
324	306 307 309	12/17/2007	ТКМ	
324	300	12/17/2007	TKM	
600	411 419 427	12/17/2007	TKM	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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